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Depth-resolved cathodoluminescence spectroscopy of silicon supersaturated with sulfur

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We investigate the luminescence of Si supersaturated with S (Si:S) using depth-resolved cathodoluminescence spectroscopy and secondary ion mass spectroscopy as the S concentration is varied over 2 orders of magnitude (10^{18}–10^{20} \text{cm}^{-3}). In single-crystalline supersaturated Si:S, we identify strong luminescence from intra-gap states related to Si self-interstitials and a S-related luminescence at 0.85 eV, both of which show a strong dependence on S concentration in the supersaturated regime. Sufficiently high S concentrations in Si (>10^{20} \text{cm}^{-3}) result in complete luminescence quenching, which we propose is a consequence of the overlapping of the defect band and conduction band. © 2013 American Institute of Physics. [http://dx.doi.org/10.1063/1.4788743]

The ability to tailor the optoelectronic properties of Si by doping with S has been an active area of research for several decades. At equilibrium concentrations (10^{16}–10^{17} \text{cm}^{-3}), Si doped with S (Si:S) offers a potential route to high-efficiency Si-based light emission due to metastable, optically active S-complexes. In a different regime of doping, Si doped with S to beyond-equilibrium concentrations (10^{18}–10^{20} \text{cm}^{-3}) was found to exhibit enhanced sub-band gap absorption and has been used to fabricate photodiodes with increased gain and extended optoelectronic response down to energies less than 0.5 eV. The changes in the optoelectronic properties of Si induced by supersaturated concentrations of chalcogens (S, Se, Te) exhibit a strong concentration dependence, which has been related both theoretically and experimentally to impurity-induced changes to the band structure. Although S in Si at dilute concentrations affects luminescence and, at supersaturated concentrations, drastically affects the optoelectronic properties, the effects of supersaturated concentrations of S on the luminescence of Si remains unexplored.

The controlled synthesis of single-crystalline Si doped with S above the equilibrium solubility limit can be achieved using ion implantation followed by pulsed laser melting (PLM). One important consequence of this technique is that the resulting dopant profile exhibits a surface layer that is uniformly doped and, beneath that, a concentration tail that decays over hundreds of nanometers. As a result, the optoelectronic properties of supersaturated Si:S exhibit a strong depth-dependence. The inhomogeneous doping makes it challenging to study the relationship between band structure and S concentration through bulk characterization; so far, iterative characterization and etching have been needed to characterize how material properties change with depth and thus with S concentration.

In this study, we combine depth-resolved cathodoluminescence (CL) spectroscopy and secondary ion mass spectroscopy (SIMS) to investigate the relationship between luminescence and dopant concentration in Si doped with S to beyond-equilibrium concentrations. A sulfur-related sub-band gap luminescence is reported at 0.85 eV, distinct from the S-related luminescent centers previously observed at dilute S concentrations. We identify a S-concentration threshold above which all luminescence is quenched, and correlation with other bulk characterization techniques suggests that the luminescent quenching may be related to S impurity-band overlap with the conduction band.

S-supersaturated Si was prepared by ion implantation of (100) Si (p-type, 10–20 \text{Ω-cm}, Czochralski-grown) with ^{32}\text{S}^{+} ions at 95 keV and at 7° off-normal to prevent channeling, followed by PLM. To study concentration dependence, four different wafers were implanted with S doses of 1 \times 10^{16} \text{cm}^{-2}, 3 \times 10^{15} \text{cm}^{-2}, 1 \times 10^{15} \text{cm}^{-2}, and 3 \times 10^{14} \text{cm}^{-2} prior to PLM with XeCl irradiation (308 nm, 25 ns at full width at half maximum, 50 ns total duration). Each sample received four consecutive XeCl pulses at fluences of 1.7, 1.7, 1.7, and 1.8 J/cm². To ensure complete amorphization prior to PLM, the 3 \times 10^{14} \text{cm}^{-2} and 1 \times 10^{15} \text{cm}^{-2} S-implanted samples were pre-amorphized with a Si implantation of 3 \times 10^{15} \text{cm}^{-2} before S implantation. To separate the effects of ion implantation and pulsed laser melting from S-related effects, we also implanted a Si wafer with 1 \times 10^{16} \text{cm}^{-2} Si prior to PLM. All samples presented in this work were irradiated under identical conditions described above and, in the following, will be referred to solely by their implantation dose. The resulting S concentration profiles were determined by SIMS for the samples implanted with S at doses of 1 \times 10^{16} \text{cm}^{-2} and 3 \times 10^{15} \text{cm}^{-2}. The post-PLM concentration profiles for the 1 \times 10^{15} \text{cm}^{-2} and 3 \times 10^{14} \text{cm}^{-2} dose samples were approximated by scaling down the SIMS S profiles of the 1 \times 10^{16} \text{cm}^{-2} and 3 \times 10^{15} \text{cm}^{-2} dose samples.

Depth-resolved CL was carried out with a commercial Gatan monoCL system on an S360 Cambridge Scanning...
Electron Microscope. The CL system is equipped with a Ge photodiode to detect near infrared emission, sensitive from 600 to 1700 nm (2.0 eV–0.7 eV). All the CL experiments were performed at liquid nitrogen temperature (77 K) with a dwell time per pixel of 67 ns and an acquisition time of 3 ms per wavelength step (1 nm). In the depth-dependent CL analyses, we used accelerating voltages of both 5 and 10 kV, keeping the total power density constant at 2 × 10⁶ W/cm². The total power density was calculated as the product of the accelerating voltage and the beam current, divided by the volume probed. The probed area was 120 × 80 μm² and the probed depth at 5 kV and 10 kV was estimated using Monte Carlo simulation of the electron trajectories. To illustrate the depth-sensitivity of the electron-material interactions, we plot in Figure 1 the distribution of electron scattering events through which the electron beam loses 60% of its starting energy in the Monte Carlo simulations.

An important consideration when conducting depth-resolved CL of Si:S is the influence of the changing S concentration on self-absorption, as the sub-band gap absorption is strongly affected by the degree of S supersaturation in Si. The upper-limit of these effects can be calculated using the reported concentration-dependent values of αd of Si:S, where α is the absorption coefficient and d is the effective thickness. We use the Beer-Lambert law to estimate the changes in self-absorption when increasing from S doses of 3 × 10¹⁴ cm⁻² to 1 × 10¹⁶ cm⁻² and find that the maximum expected decrease in luminescent intensity due to the increased S concentration is 34% in this doping regime. The effects of self-absorption may complicate the quantification of the observed trends in luminescence, but we note that in the following investigations, all trends of modulated luminescence with changes in the doping dose (which could include self-absorption effects) significantly exceed 34%. Therefore, qualitative discussions of the observed trends in luminescence are possible in our case.

We first isolate luminescence due to PLM-induced point defects by investigating the CL of Si samples implanted with 1 × 10¹⁶ cm⁻² Si compared with that of an untreated Si wafer. At 5 kV (Figure 2(a)) and 10 kV (Figure 2(b)), the pristine Si wafer shows only a peak centered at 1.1 eV corresponding to the band-to-band transition in Si (BB-line). At both 5 kV and 10 kV, the 1 × 10¹⁶ cm⁻² Si-dose sample exhibits decreased intensity of the BB-line, and a broad emission at 0.99 eV simultaneously appears. The decrease in intensity of the BB-line is attributed to increased nonradiative recombination due to PLM-induced point defects. The luminescence at 0.59 eV is identical to the band observed by Pankove and Wu following ion implantation of Si with S and annealing at 300 °C in H₂. This luminescent feature is attributed to the increased volume of unaffected Si that is probed using 10 kV accelerating voltage (Figure 1).

Next, we elucidate the effects of S-supersaturation by comparing Si implanted with Si to Si implanted with S at an identical dose (1 × 10¹⁶ cm⁻²). The CL spectra of the 1 × 10¹⁶ cm⁻² S-supersaturated sample taken at 5 kV (Figure 2(a)), which probes the most highly doped region (Figure 1), exhibit significantly reduced overall intensity without clearly resolvable luminescent bands. Increasing the accelerating voltage to 10 kV, thus probing the tail of the doped profile, results in the appearance of the BB-line at 1.1 eV and a CL band centered around 0.85 eV. The luminescence at 0.85 eV does not appear in either the 5 kV or 10 kV spectra from the Si-implanted sample and is therefore related to the presence of S. Here, we note that the S-related luminescence at 0.85 eV observed in our supersaturated samples is different from the metastable luminescence centers at 0.82 eV (1.5 μm) and 0.94 eV (1.32 μm) that have been observed in Si containing equilibrium concentrations of S (concentrations 1-3 orders of magnitude lower than investigated here).

To better understand the effect of S-supersaturation on the implantation-related band at 0.99 eV and the S-related band around 0.85 eV, the implanted S dose was decreased from 1 × 10¹⁶ cm⁻² to as low as 3 × 10¹⁴ cm⁻² and the...
resulting luminescence was measured at 5 kV (Figure 3(a)) and 10 kV (Figure 3(b)). When the S dose is decreased to $3 \times 10^{15} \text{cm}^{-2}$, the band at 0.99 eV appears, which has been attributed to Si self-interstitials.\textsuperscript{25–27} Recall this band was observed in the $1 \times 10^{16} \text{cm}^{-2}$ Si-implanted sample but absent in the S-implanted sample of the same dose. Furthermore, we observe a strong increase in the intensity of the 0.99 eV band with decreasing S dose. Lower doses of S than used in this study ($1 \times 10^{14} \text{cm}^{-2}$), followed by PLM, have been used to fabricate light emitting diodes based on zero-phonon luminescence from the W-line (1.018 eV),\textsuperscript{28} which is also attributed to Si self-interstitials.\textsuperscript{25–27} The concentration dependence of this luminescence on S also attributed to Si self-interstitials caused by the implantation process,\textsuperscript{27} but the dependence of this luminescence on S concentration was not investigated. It has been previously reported that the intensity of the 0.99 eV band increases upon annealing of ion-implanted Si in H\textsubscript{2} ambient\textsuperscript{26} and this behavior was attributed to the ability of H to passivate competing non-radiative recombination pathways. S impurities have been shown to provide both radiative and non-radiative recombination pathways, and thus we attribute the decreasing 0.99 eV luminescence with increasing S concentration to the associated non-radiative recombination pathways.\textsuperscript{2,4}

The general trends in the luminescence spectra of Si:S samples at 10 kV (BB-line, 0.99 eV band, and 0.85 eV band) are similar to those collected at 5 kV. The band centered at 0.85 eV appears in the $3 \times 10^{15} \text{cm}^{-2}$ S-dose sample at 5 kV, increases in intensity as the dose is decreased further to $1 \times 10^{15} \text{cm}^{-2}$, and remains constant as the S dose is further decreased to $3 \times 10^{14} \text{cm}^{-2}$, which indicates that this luminescence band is relatively insensitive to S concentration in this regime. This is in stark contrast to the concentration dependence of the 0.99 eV band, which monotonically decreases with increasing S concentration.

Using ion implantation and PLM to synthesize Si:S, we have identified a S-related luminescence at 0.85 eV. There are two known S states with energy levels that align well with the 0.85 eV band: a neutral S substitutional atom\textsuperscript{29} or a charged S dimer,\textsuperscript{30} with energies 320 meV and 371 meV below the conduction band, respectively. However, S-related luminescence at these energies has not been previously reported. One possibility is that increased impurity–impurity interactions at supersaturated concentrations lead to changes in the luminescent behavior of S impurities, but we would expect such a phenomenon to show strong concentration dependence. Alternatively, it is possible that the band at 0.85 eV is related to a metastable S complex arising from the PLM process. The melting and ultrafast resolidification during PLM represents a unique processing regime that, as evidenced by the supersaturated concentrations of S achieved, produces metastable impurity distributions. Furthermore, metastable luminescent S-complexes have been previously observed, though at different energy levels: S complexes observed at dilute S-concentrations at 0.82 eV and 0.94 eV form only after heating with a blow torch and quenching in ethylene glycol.\textsuperscript{45} Further investigations will be necessary to understand the source of the S-related luminescence at 0.85 eV.

Finally, the concentration dependence of the luminescence from supersaturated Si:S provides evidence of the S-induced changes in the band structure as concentrations...
approach 1 at. %. In the 5 kV spectra (Figure 3(a)), each luminescent band (BB-line, 0.99 eV, 0.85 eV) shows a unique concentration dependence as the dose is increased from $3 \times 10^{14}$ cm$^{-2}$ to $3 \times 10^{15}$ cm$^{-2}$, but are suppressed when the dose is further increased to $1 \times 10^{16}$ cm$^{-2}$. The lack of luminescence from the $1 \times 10^{16}$ cm$^{-2}$ S-implanted sample at 5 kV suggests that a S concentration around $3.5 \times 10^{17}$ cm$^{-3}$ (0.7 at. %) quenches luminescence from Si:S (Figure 1). Furthermore, the onset of quenching is visible in the $3 \times 10^{15}$ cm$^{-2}$ spectra at 5 kV where the intensity of the 0.85 eV and the BB-line is significantly less than the level they maintained from $3 \times 10^{14}$ cm$^{-2}$ to $3 \times 10^{15}$ cm$^{-2}$. Within the resolution of this characterization, we can say that the onset of quenching occurs around or just above the peak concentrations of S in the $3 \times 10^{15}$ cm$^{-2}$ sample ($1 \times 10^{20}$ S cm$^{-3}$ or 0.2 at. %).

Previous investigations into the optoelectronic properties of supersaturated Si:S indicate the emergence of an impurity band from impurity levels in the gap with increasing chalcogen concentration, leading to drastic changes to the band structure at a concentration threshold similar to where we observe luminescent quenching ($\geq 1 \times 10^{20}$ cm$^{-3}$). Combined computational experiments of the effect of increasing chalcogen concentration on the band structure suggests an insulator-metal transition due to the overlapping of the defect and conduction bands at S concentrations above $1 \times 10^{20}$ cm$^{-3}$, and this model accurately predicts the observed increased sub-band gap absorptance.

The concentration thresholds at which the chalcogen-induced defect band is predicted to overlap with the conduction band ($1 \times 10^{20}$ cm$^{-3}$) and at which a S-induced insulator-metal transition has been observed experimentally agree well with the onset of quenching that we observe using depth-resolved CL spectroscopy ($\geq 1 \times 10^{20}$ cm$^{-3}$). Thus, our investigation of the concentration-dependence of luminescence agrees with the band-overlap model, as the impurity and conduction band overlapping could feasibly result in luminescent quenching near the band edge. Finally, although the sub-band gap absorptance and impurity-mediated conduction increases with increasing S concentration, we have shown that S-induced changes in the band structure at concentrations above $1 \times 10^{20}$ cm$^{-3}$ are not conducive to enhancing sub-band gap luminescence. These investigations highlight, however, the orders of magnitude of S-supersaturation ($10^{18}$–$10^{19}$ cm$^{-3}$) that could potentially allow for simultaneous sub-band gap absorptance, increased gain and extended response in photodiodes, and luminescence.

In summary, we have combined depth-resolved CL and SIMS to elucidate the luminescent behavior of Si:S and the effect of varying the concentration within the supersaturated regime. We find that band-to-band luminescence is reduced by the presence of S and further decreases with increasing S concentration. Luminescence at 0.99 eV, attributed to Si self-interstitial clusters, shows a pronounced increase in intensity with decreasing S concentration which we attribute to a reduction in competing non-radiative recombination pathways. We report S-related luminescence around 0.85 eV that corresponds well with the energy levels of a substitutional S atom or a charged S dimer in Si, though further studies are needed to elucidate its exact nature and its appearance only at supersaturated concentrations of S. Above $1 \times 10^{20}$ S cm$^{-3}$, we observe quenching of all luminescence, the onset of which correlates well with predicted overlapping of the defect band and conduction band. This work demonstrates the efficacy of depth-resolved CL for probing the depth dependence of luminescence in alloys fabricated using ion implantation and pulsed laser melting and reveals the concentration-dependent luminescent properties of S-supersaturated Si.

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